

## AMENDMENT TRANSMITTAL LETTER (Large Entity)

Applicant(s): Yoshi Ono

Docket No.

SLA0669

Serial No  
10/602,194Filing Date  
June 23, 2003Examiner  
Khiem D. NguyenGroup Art Unit  
2823

Invention: Low Temperature Nitridation of Silicon

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## TO THE COMMISSIONER FOR PATENTS:

MAY 23, 2005

Transmitted herewith is an amendment in the above identified application.

The fee has been calculated and is transmitted as shown below.

## CLAIMS AS AMENDED

	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER OF EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE
TOTAL CLAIMS	20 -	20 =	0	x \$50.00	\$0.00
INDEP. CLAIMS	3 -	3 =	0	x \$200.00	\$0.00
Multiple Dependent Claims (check if applicable) _____					\$0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0.00

- No additional fee is required for amendment.  
 Please charge Deposit Account No. 19-1457 in the amount of \$0.00.  
 A duplicate copy of this sheet is enclosed.  
 A check in the amount of \_\_\_\_\_ to cover the filing fee is enclosed.  
 The Commissioner is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 19-1457.  
 A duplicate copy of this sheet is enclosed.  
 Any additional fees required under 37 C.F.R. 1.16.  
 Any patent application processing fees under 37 C.F.R. 1.17.

Dated: May 23, 2005

David C. Ripma, Reg. No. 27,672

I hereby certify that this correspondence is being facsimile transmitted to the United States Patent and Trademark Office under 37 C.F.R. §1.8 at Fax No. (403) 872-9306 on May 23, 2005.

David C. Ripma, Reg. No. 27,672

Note: Each paper must have its own certificate of transmission, or this certificate must identify each submitted paper. The papers submitted include:

- |   |           |
|---|-----------|
| <input checked="" type="checkbox"/> This Amendment Transmittal Letter (Include Duplicate) | 2 page(s) |
| <input checked="" type="checkbox"/> Response under 37 CFR § 1.111                         | 6 page(s) |
| <input checked="" type="checkbox"/> Attachments   | 7 page(s) |
| _____   | pages     |

Total pages, including this Transmittal: 15

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SLA0669

Serial No 10/602,194	Filing Date June 23, 2003	Examiner Khiem D. Nguyen	Group Art Unit 2823
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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Serial No.: 10/602,194  
Applicant: Yoshi Ono  
Filed: June 23, 2003  
Group #: 2823  
Examiner: Khiem D. Nguyen

Confirmation Number: 9996

Docket No: SLA.0669  
Customer No: 27518  
For: Low Temperature Nitridation of Silicon

MS AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

**RESPONSE TO OFFICE ACTION UNDER 37 C.F.R. § 1.111**  
**Introductory Comments**

In response to the Office Action dated March 15, 2005, please amend the above-identified Application as follows:

**Amendment to the Specification** None

**Amendment to the Claims** None

**Amendment to the Drawings** None

**Remarks/Arguments** begin on page 2 of this paper.

**An Appendix** is not included.

Page 1 Response to Office Action under 37 C.F.R. § 1.111 for Serial No. 10/602,194